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CLAIMS

What is claimed is:

1. An apparatus for sensing a characteristic of a droplet, the apparatus comprising:

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a first plate and a second plate forming a capacitor, the first plate and the second plate being disposed to allow a droplet to pass between them; and

an amplifier coupled to the first plate, the amplifier configured to generate an output signal indicative of a characteristic of the droplet.

- The apparatus of claim 1 further comprising:
 a bias voltage coupled to the second plate; and
 wherein the amplifier includes a charge sensitive amplifier.
- 3. The apparatus of claim 2 further comprising an input transistor coupled between the amplifier and the first plate.
 - 4. The apparatus of claim 1 wherein the characteristic includes drop mass.
 - 5. The apparatus of claim 1 wherein the characteristic includes drop velocity.
- 6. The apparatus of claim 1 wherein the droplet is from an ink-jet print head configured to deposit material on a wafer.
- 7. The apparatus of claim 1 wherein the output signal is employed to calibrate a nozzle that dispensed the droplet.
- 8. The apparatus of claim 1 wherein the apparatus is included in an integrated circuit manufacturing equipment.

- 9. The apparatus of claim 1 wherein the output signal is provided to a signal processing device.
- 10. The apparatus of claim 9 wherein the signal processing device includes a computer.
- The apparatus of claim 1 wherein the apparatus is part of a sensor module located near a wafer processing chamber to allow calibration of a print head that dispensed the droplet.
 - 12. The apparatus of claim 11 wherein the print head includes a plurality of nozzles.
 - 13. An apparatus comprising:
 means for dispensing a droplet;
 means for detecting the droplet; and
 means for generating a signal indicative of a characteristic of the droplet.
 - 14. The apparatus of claim 13 wherein the characteristic includes drop mass.
 - 15. The apparatus of claim 13 wherein the characteristic includes drop velocity.
 - 16. A method of sensing a droplet characteristic, the method comprising: dispensing a droplet;

detecting the presence of the droplet between two parallel plates that form a capacitor; and

generating an output signal indicative of a characteristic of the droplet.

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- 17. The method of claim 16 wherein the method is performed for an integrated circuit manufacturing equipment.
 - 18. The method of claim 16 further comprising:
 processing the output signal to sense drop mass.
- 19. The method of claim 16 further comprising:processing the output signal to sense drop velocity.
 - 20. The method of claim 16 further comprising: calibrating a nozzle based on the output signal.
 - 21. An apparatus for tuning a mechanism for dispensing materials: a sensor configured to detect a passing material;

an amplifier coupled to the sensor, the amplifier configured to generate an output signal indicative of a characteristic of the material; and

a control system configured to generate a tuning signal based on the output signal, the tuning signal being provided to a mechanism that dispensed the material.

- 22. The apparatus of claim 21 wherein the output signal is indicative of a mass of the material.
- 23. The apparatus of claim 21 wherein the output signal is indicative of a drop velocity of the material.
- 24. An apparatus for sensing a characteristic of a material, the apparatus comprising:

a capacitive sensor configured to sense a passing material; and an amplifier coupled to the capacitive sensor, the amplifier configured to generate an output signal indicative of a characteristic of the material.

- 25. The apparatus of claim 24 wherein the characteristic includes drop mass.
- 5 26. The apparatus of claim 24 wherein the characteristic includes drop velocity.